

Attorney's Docket 040021-0307298 Client Reference: OPP 030894 US

Attorney's Docket 040021-0307298 Client Reference: OPP 030894 US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation No: 9855

**GEON-OOK PARK** 

Application No.: 10/739,202

Group Art Unit: 2812

Filed: December 19, 2003

Examiner: Evan Pert

Title: FORMATION METHOD OF GATE ELECTRODE IN SEMICONDUCTOR

## AMENDMENT UNDER 35 U.S.C. § 3.112

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Before passing the above-identified application into issuance, please amend the application as follows: